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Appl. No. 10/683,801

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Assignee Micron Technology, Inc.

Group Art Unit 2812

Examiner Nguyen, H.

Attorney's Docket No. MI22-2411

Title: Methods of Cleaning Surfaces of Copper-Containing Materials, and Methods of Forming Openings to Copper-Containing Substrates

RESPONSE TO MARCH 11, 2004 OFFICE ACTION

To:

MS Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

From:

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<u>AMENDMENTS</u>

Introductory Comments

In reply to the Office Action of March 11, 2004, applicant amends and remarks as follows.